# Model-Based Control and Virtual Sensing with Application to a Vertical Furnace

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- Vertical Furnace Model
- □ Closed-loop Simulation
- **Temperature Uniformity**
- □ Sensor Failure
- **Estimator Design**
- □ Failure Accommodation
- **G** Summary

### **The Vertical Furnace**



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### **Load Position vs Process Position**



**SC SOLUTIONS** 

- □ Full non-linear radiation and conduction model
- □ Two radiation bands ( < 3.3 microns >= 3.3 microns )
- Temperature dependent silicon properties (IR transmission and thermal conductivity)
- □ Real-time wafer stack vertical position included
- □ Fast model suitable for real-time execution

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### **Model-Based Control Design**



**AEC/APC 2008** 

## **Closed-loop Simulation**



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## **Baseline Wafer Uniformity, No Tuning**



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## Wafer Temperature Uniformity: Optimal



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□ What happens if a sensor fails?

- o Could abort, but that might ruin a batch of wafers
- Could hold last good value of power, but that might be bad
- **O Use physics-based model to build a Model-based Estimator**

### **Sensor Failure**

#### □ Simulate a failure where sensor 1 drops out at t = 2000 s





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## **Estimator Design - Background**

A linear system with states x, inputs u, and outputs y can be written as

$$\dot{x} = Ax + Bu + w y = Cx + Du + \nu$$

where w is system noise and  $\nu$  is measurement noise. An estimator can be built that tracks the output y. This estimated output is  $\hat{y}$  and depends on states  $\hat{x}$  and can be written as

$$\dot{\hat{x}} = A\hat{x} + Bu + L(y - \hat{y})$$
$$\hat{y} = C\hat{x} + Du$$

where  $L = PC^T R^{-1}$  and P satisfies the Riccati equation

$$\dot{P} = AP + PA^T + BQB^T - PC^T R^{-1}CP$$

Here Q and R are weighting matrices we can tune to vary performance.

### **Estimator Design - Example**



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### **Failure Accommodation**



### **Failure Accommodation**



## **Failure Accommodation**



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## Summary

### Developed detailed heat transfer model of furnace.

- Realistic and complex radiation properties
- **Dynamic geometry (wafer stack position)**
- o Fast, real-time model
- Developed model-based multivariable feedback controller.
  - o Robust regulation and tracking
  - o No overshoot
  - o Good temperature uniformity
- Developed model based estimator
  - o Use as virtual sensor to predict unmeasured temperatures.
  - Demonstrated use for sensor failure accommodation.